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US patent number 7762871,

US patent number 7759165, and

US Publication number 20110143640

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**Assignments on the Web > Patent Query****Patent Assignment Details****NOTE: Results display only for issued patents and published applications. For pending or abandoned applications please consult USPTO staff.**Reel/Frame: [026526/0989](#)

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1	Patent #: 7762871	Issue Dt: 07/27/2010	Application #: 11369876	Filing Dt: 03/06/2006
	Publication #: US20060199471	Pub Dt: 09/07/2006		
	Title: PAD CONDITIONER DESIGN AND METHOD OF USE			
2	Patent #: 7815778	Issue Dt: 10/19/2010	Application #: 11562310	Filing Dt: 11/21/2006
	Publication #: US20070131564	Pub Dt: 06/14/2007		
	Title: ELECTRO-CHEMICAL MECHANICAL PLANARIZATION PAD WITH UNIFORM POLISH PERFORMANCE			
3	Patent #: NONE	Issue Dt:	Application #: 11562346	Filing Dt: 11/21/2006
	Publication #: US20070224925	Pub Dt: 09/27/2007		
	Title: Chemical Mechanical Polishing Pad			
4	Patent #: 8075745	Issue Dt: 12/13/2011	Application #: 11576942	Filing Dt: 10/16/2007
	Publication #: US20080164153	Pub Dt: 07/10/2008		
	Title: ELECTRO-METHOD AND APPARATUS FOR IMPROVED CHEMICAL MECHANICAL PLANARIZATION PAD WITH UNIFORM POLISH PERFORMANCE			
5	Patent #: 7530880	Issue Dt: 05/12/2009	Application #: 11576944	Filing Dt: 04/21/2008
	Publication #: US20080268760	Pub Dt: 10/30/2008		
	Title: METHOD AND APPARATUS FOR IMPROVED CHEMICAL MECHANICAL PLANARIZATION PAD WITH PRESSURE CONTROL AND PROCESS MONITOR			
6	Patent #: 7846008	Issue Dt: 12/07/2010	Application #: 11697622	Filing Dt: 04/06/2007
	Publication #: US20080248734	Pub Dt: 10/09/2008		
	Title: METHOD AND APPARATUS FOR IMPROVED CHEMICAL MECHANICAL PLANARIZATION AND CMP PAD			
7	Patent #: NONE	Issue Dt:	Application #: 11968442	Filing Dt: 01/02/2008
	Publication #: US20080318505	Pub Dt: 12/25/2008		
	Title: CHEMICAL MECHANICAL PLANARIZATION PAD AND METHOD OF USE THEREOF			
8	Patent #: NONE	Issue Dt:	Application #: 12141876	Filing Dt: 06/18/2008
	Publication #: US20090011679	Pub Dt: 01/08/2009		
	Title: METHOD OF REMOVAL PROFILE MODULATION IN CMP PADS			
9	Patent #: NONE	Issue Dt:	Application #: 12141907	Filing Dt: 06/18/2008
	Publication #: US20090313905	Pub Dt: 12/24/2009		
	Title: METHOD AND APPARATUS FOR ASSEMBLY OF CMP POLISHING PADS			
10	Patent #: 7759165	Issue Dt: 07/20/2010	Application #: 12395681	Filing Dt: 03/01/2009
	Title: NANOSPRING			
11	Patent #: NONE	Issue Dt:	Application #: 12431119	Filing Dt: 04/28/2009
	Publication #: US20090266002	Pub Dt: 10/29/2009		
	Title: POLISHING PAD AND METHOD OF USE			

12	Patent #: NONE Publication #: US20090270019 Title: POLISHING PAD COMPOSITION AND METHOD OF MANUFACTURE AND USE	Issue Dt: Pub Dt: 10/29/2009	Application #: 12431515	Filing Dt: 04/28/2009
13	Patent #: NONE Publication #: US20100130112 Title: POLISHING PAD WITH ENDPOINT WINDOW AND SYSTEMS AND METHOD USING THE SAME	Issue Dt: Pub Dt: 05/27/2010	Application #: 12616323	Filing Dt: 11/11/2009
14	Patent #: NONE Publication #: US20110143640 Title: PAD CONDITIONER AND METHOD	Issue Dt: Pub Dt: 06/16/2011	Application #: 12636644	Filing Dt: 12/11/2009
15	Patent #: 8066555 Publication #: US20100203815 Title: POLISHING PAD	Issue Dt: 11/29/2011 Pub Dt: 08/12/2010	Application #: 12676318	Filing Dt: 04/27/2010
16	Patent #: NONE Publication #: US20110143539 Title: POLISHING PAD WITH ENDPOINT WINDOW AND SYSTEMS AND METHOD USING THE SAME	Issue Dt: Pub Dt: 06/16/2011	Application #: 12991097	Filing Dt: 02/28/2011
17	Patent #: NONE Publication #: US20110244768 Title: POLISHING PAD AND METHOD OF USE	Issue Dt: Pub Dt: 10/06/2011	Application #: 13162508	Filing Dt: 06/16/2011

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